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10/006,376

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

APPLICANT
Joe G. HOFFMAN et al.FILING DATE
December 10, 2001GROUP
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Examiner Initials	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication (MM-YYYY)
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these patents
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Kevin P. Lemay

4/7/04

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XXX	G.A. Blyum et al, "Use of Radioactive Isotopes to Study Liquid-Vapor Equilibrium in Binary Systems Formed by Hydrofluoric Acid with Microimpurities of Some Elements," Article No. 81:177347.		
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Examiner Signature	Kevin C. Leung	Date Considered	4/7/04

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